

AF12813



PATENT  
Customer No. 22,852  
Attorney Docket No. 08244.0032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Sung-Chan PARK et al. ) Group Art Unit: 2813  
Application No.: 09/998,303 ) Examiner: Nguyen, Thanh T.  
Filed: December 3, 2001 )  
For: METHOD FOR FORMING )  
CONTACT HOLE AND SPACER )  
OF SEMICONDUCTOR DEVICE )

**RECEIVED**

FEB 23 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE AND REQUEST FOR RECONSIDERATION**

In reply to the Final Office Action of November 19, 2003, Applicants request reconsideration of the subject application for the reasons set forth below in the Remarks section.

**Remarks** begin on page 2 of this paper.

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